



PATENT APPLICATION

Ref #
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Tsuyoshi KANEKO et al.

Group Art Unit: 2812

Application No.: 10/649,891

Examiner: A. STEVENSON

Filed: August 28, 2003

Docket No.: 116565

For: OPTICAL COMPONENT AND
MANUFACTURING METHOD THEREOF,
MICROLENS SUBSTRATE AND
MANUFACTURING METHOD THEREOF,
DISPLAY DEVICE, AND IMAGING DEVICE

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s)
continued examination.

☒ Applicants further request entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper
under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 173343 in the amount of ☒ \$790.00 as payment of the fees
set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees
or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two
duplicate copies of this page are enclosed.

Respectfully submitted,

J. Adam Neff

James A. Oliff
Registration No. 27,075

J. Adam Neff
Registration No. 41,218

JAO:JAN/sqb

Date: November 28, 2005

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

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